Fermi Level in Semiconductor

BPT: 401: Electronics and Modern Physics

Tutorial - 3

Fermi level in Intrinsic Semiconductor

At absolute zero, fermions will fill up all available energy states below a level E_F called the Fermi energy with one (and only one) particle. They are constrained by the Pauli exclusion principle. At higher temperatures, some are elevated to levels above the Fermi level.

See the Maxwell-Boltzmann distribution for a general discussion of the exponential term. Por low temperatures,

The quantum difference

those energy states below

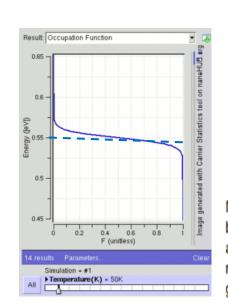
the Fermi energy EF have

a probability of essentially 1

and those above the Fermi

energy essentially zero.

Fermi level is the highest occupied energy level of free electrons at 0 K (highest possible Quantum state of free electrons at 0 K) and Fermi energy is the energy of electrons in Fermi level

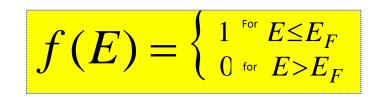


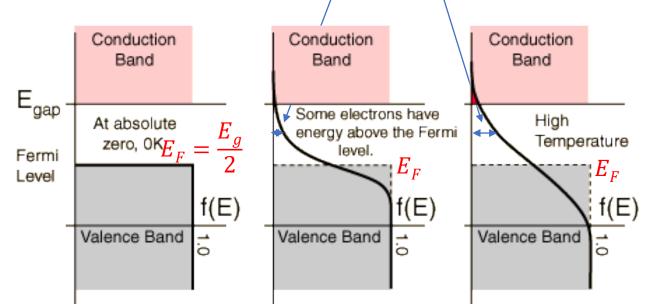
which arises from the

fact that the particles

are indistinguishable.

Probability of free electron occupancy on the energy level above E_F increases with increasing temperature



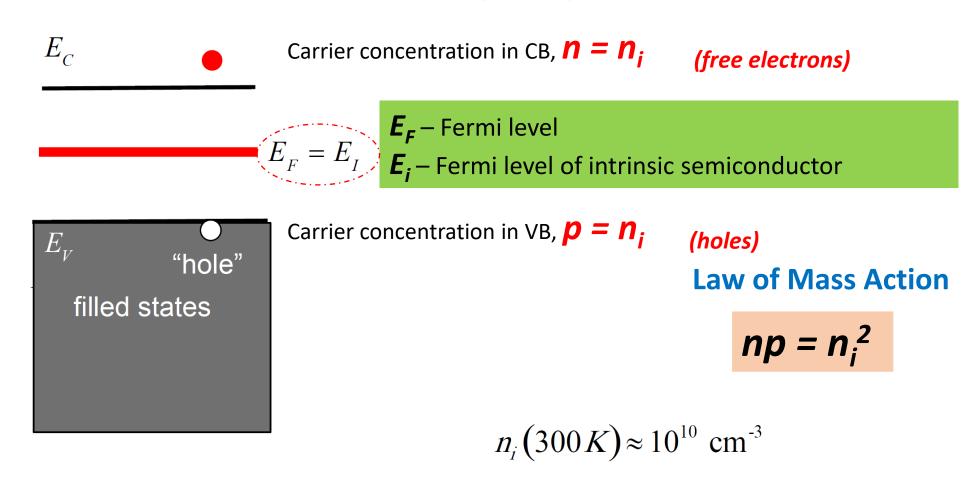


No electrons can be above the valence band at 0K, since none have energy above the Fermi level and there are no available energy states in the band gap.

At high temperatures, some electrons can reach the conduction band and contribute to electric current.

Intrinsic Semiconductor and Law of Mass Action

No. of free electrons in CB = No. of holes in VB (T > 0 K) Carrier generation by **thermal excitation**;



 $n \rightarrow$ electron concentration, $p \rightarrow$ holes concentration, $n_i \rightarrow$ intrinsic charge carrier concentration

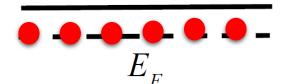
Fermi level in N type and P type Semiconductor

N type

$$n_{0N} \approx N_D^+$$

At OK, No. of free $e^-s = No.$ of donor ions

$$E_{c}$$



 $E_{_{V}}$ filled states

$$At T = 0 K$$

$$f_0(E) = \frac{1}{1 + e^{(E-E_F)/k_BT}}$$

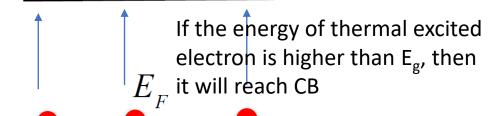
$$E = E_F \to f_0(E) = \frac{1}{2}$$

$$E \ll E_F \rightarrow f_0(E) = 1$$

$$E >> E_F \to f_0(E) = 0$$

P type

$$p_{0P} \approx N_A^-$$
 At OK, No. of holes in VB = No. of acceptor ions E_C





Thermally excited electrons

N type Semiconductor (free electrons concentration)

 N_D is the density of pentavalent or donor atoms (e.g. Phosphor)

$$n_{0N} \approx N_D^+$$

$$E_{F(n-type)} = E_I + K_B T \ln(N_D/n_i)$$

Where, E_I is the Fermi energy of intrinsic semiconductor

$$N_D/n_i = \exp\left(\frac{E_F - Ei}{K_B T}\right)$$

$$n_0 \approx N_D^+$$

$$E_i$$
 $N_D = n_0 = n_i \exp\left(\frac{E_F - Ei}{K_B T}\right)$

$$n_0 p_0 = n_i^2$$

$$E_{\scriptscriptstyle V}$$
 filled states

 n_0 is free electrons concentration in N type semiconductor

$$p_0 = n_i^2 / N_D^+$$

$$n_0 = N_D \approx 10^{17} \text{ cm}^{-3}$$

$$n_i (300 K) \approx 10^{10} \text{ cm}^{-3}$$

$$p_0 \approx 10^3 \text{ cm}^{-3}$$

P type Semiconductor (holes concentration)

 N_{Δ} is the density of trivalent or acceptor atoms (e.g. Boron)

$$E_{F(p-type)} = E_i - K_B T \ln(N_A/n_i)$$

Where, E₁ is the Fermi energy of intrinsic semiconductor

$$E_{C}$$

$$N_A/n_i = \exp\left(\frac{E_i - EF}{K_B T}\right)$$
 $p_0 \approx N_A^-$

$$p_0 \approx N_A$$

$$\mathbf{E}_i \quad \mathbf{p}_0 = \mathbf{n}_i \exp\left(\frac{E_i - EF}{K_B T}\right)$$

$$n_0 p_0 = n_i^2$$

$$E_{_V}$$
 "holes" filled states

 p_0 is the hole concentration in VB

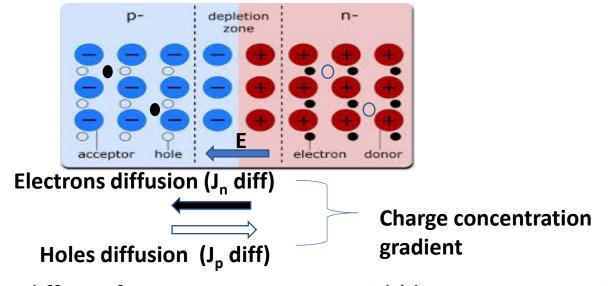
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$$n_0 \approx 10^3 \text{ cm}^{-3}$$

Formation of PN junction



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      J_n \  \, \text{diff} = qD \frac{\partial n}{\partial x} \\       \frac{\partial n}{\partial x} \  \, \text{is the concentration gradient} \\            D \  \, \text{is the diffusion coefficient} \\            q \  \, \text{is the carrier charge} \\            J_n \  \, \text{drift} = q\mu_n nE \\            \mu_{n-} \  \, \text{Carrier mobility} \\            n - \text{charge carrier concentration} \\            E- \  \, \text{is the built-in electric field}
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As election diffuses from N to P type material (due to concentration gradient), it leaves positive charges (holes) in the N type and vice versa. Once a majority carrier crosses the junction, it becomes a minority carrier. It will continue to diffuse away from the junction and can travel a distance on average equal to the diffusion length before it recombines with opposite charges. The current caused by the diffusion of carriers across the junction is called a **diffusion current**. As a result an electric field (E) is developed in the junction (depleted region). This built-up electric field push the minority charge carriers, due to which a **drift current** is developed in the direction opposite to that of the direction of diffusion current. Under equilibrium, the drift current is equal and opposite to that of the diffusion current so there won't be further movement of charge carriers and the net current is zero. The electron drift current and electron diffusion current exactly balance out. Similarly, the hole current also balance out.

$$J = J_p + J_n = 0$$

$$J_p = J_{p \text{ drift}} + J_{p \text{ diff}} = 0$$

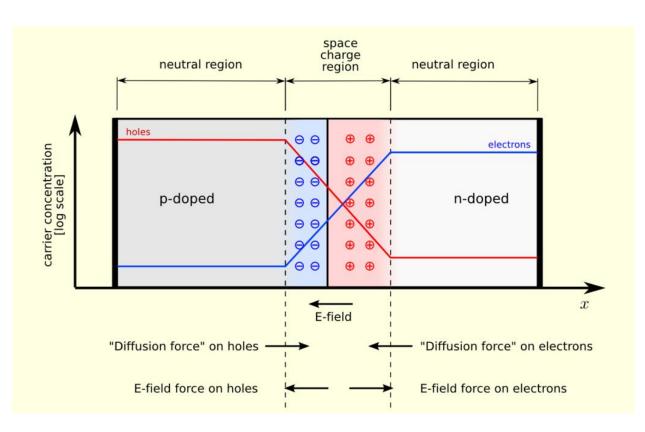
$$J_n = J_{n \text{ drift}} + J_{n \text{ diff}} = 0$$

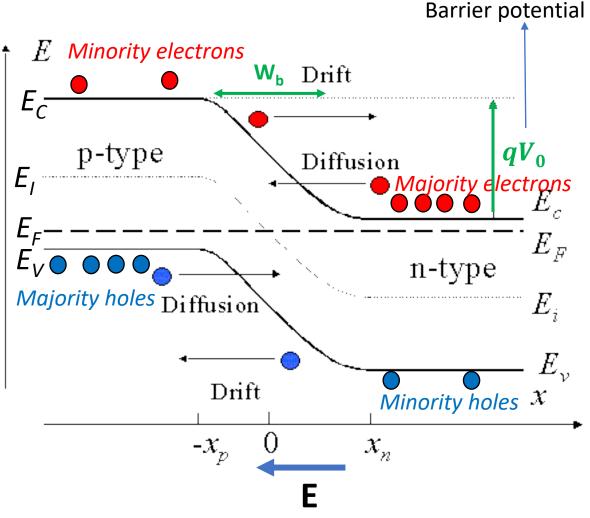
Diffusion current – majority charge carrier

Drift current – minority charge carrier

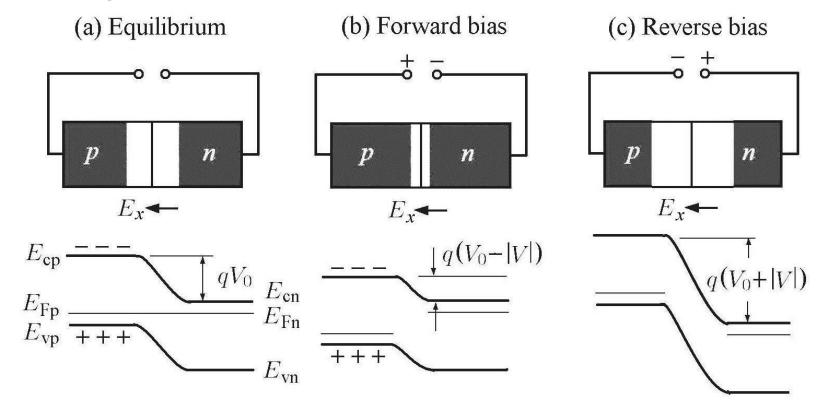
J - total current density, J_p - hole current density, J_n - electron current density

Energy Band diagram of PN junction





Effect of bias in a PN junction



(a) At equilibrium, without external bias, the diffusion current and the drift current cancel each other. (b) A positive bias voltage pushes the holes to the *n*-side and the free electrons to the *p*-side. The potential barrier is reduced. Both diffusion currents of holes and free electrons are increased. The drift currents, depending on the available carriers, are unchanged. The net current is nonzero. (c) By applying a reversed bias, the holes are pushed further back into the *p*-region and the free electrons are pushed further back into the *n*-region. The diffusion current is reduced. Only the drift current persists.